



Commissioner for Patents
Washington, DC 20231
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CONFIRMATION NO. 4190

Bib Data Sheet

SERIAL NUMBER 10/007,618	FILING DATE 11/07/2001 RULE	CLASS 438	GROUP ART UNIT 3652	ATTORNEY DOCKET NO. 00245/TL	
APPLICANTS Neil S. Casa, Arlington, MA; ** CONTINUING DATA ***** ** FOREIGN APPLICATIONS *****					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/07/2002					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged _____ Examiner's Signature _____ Initials _____		STATE OR COUNTRY MA	SHEETS DRAWING 4	TOTAL CLAIMS 57	INDEPENDENT CLAIMS 8
ADDRESS Thomas Langer, Esq. Cohen, Pantani, Lieberman & Pavane 551 Fifth Avenue Suite 1210 New York, NY 10176					
TITLE System and method for inhibiting motion of semiconductor wafers in a variable-pressure chamber					
FILING FEE RECEIVED 1826	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		